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| Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary) | Atty Docket No. | GENSP109 |
| | Application No.: | 10/726,441 |
| | Applicant | Kobayashi |
| | Filing Date | 12/02/03 |
| | Group | 2623 |
| | | Page 1 of 2 |

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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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| | | Page 2 of 2 |

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